

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	23	(johannes near2 kaeppler or frank near2 wischmeyer or gert near2 strauch).in. and cvd	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/19 23:14
L2	17	(cvd or chemical near2 vapor near2 deposit\$6) near5 (sicge or silicon near2 carbon near2 germanium)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/19 23:14
L3	75	(cvd or chemical near2 vapor near2 deposit\$6) and rotat\$5 near6 (substrate or susceptor) same horizont\$6 near4 flow	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/19 23:14
S1	2	"5871586".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 14:44
S2	2	"5788777".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 14:46
S3	195	cvd and channel near6 reactor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 14:47
S4	104	cvd and channel near6 reactor and @py<"2003"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:47
S5	47	(johannes near2 kaeppler or frank near2 wischmeyer or gert near2 strauch).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:38
S6	0	(johannes near2 kaeppler or frank near2 wischmeyer or gert near2 strauch).in. and channel near2 reactor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:38

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S7	0	(johannes near2 kaeppeler or frank near2 wischmeyer or gert near2 strauch).in. and channel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:38
S8	23	(johannes near2 kaeppeler or frank near2 wischmeyer or gert near2 strauch).in. and cvd	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/19 23:14
S9	745	activ\$5 near4 flow near2 channel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:41
S10	132593	activ\$5 near4 flow near2 channel and cvd or chemical near2 vapor near2 deposit\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:41
S11	70	activ\$5 near4 flow near2 channel and (cvd or chemical near2 vapor near2 deposit\$5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:41
S12	4	activ\$5 near4 flow near2 channel same (cvd or chemical near2 vapor near2 deposit\$5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:42
S13	8	activ\$5 near5 heat\$5 near4 flow near2 channel and (cvd or chemical near2 vapor near2 deposit\$5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:43
S14	1214	(cvd or chemical near2 vapor near2 deposit\$6) and cool\$5 near4 inlet	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 16:49
S15	140	(cvd or chemical near2 vapor near2 deposit\$6) and cool\$5 near4 inlet and rotat\$5 near6 (substrate or susceptor)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:02
S16	222	(cvd or chemical near2 vapor near2 deposit\$6) and rotat\$5 near6 (substrate or susceptor) and horizont\$6 near4 flow	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:03

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S17	75	(cvd or chemical near2 vapor near2 deposit\$6) and rotat\$5 near6 (substrate or susceptor) same horizont\$6 near4 flow	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/19 23:14
S18	38	(cvd or chemical near2 vapor near2 deposit\$6) and rotat\$5 near6 (substrate or susceptor) same horizont\$6 near4 flow and @py<"2002"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:05
S19	18	(cvd or chemical near2 vapor near2 deposit\$6) and rotat\$5 near6 (substrate or susceptor) and horizont\$6 near4 (reactor flow) and cool\$5 near3 inlet	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:07
S20	2	"4747368".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:07
S21	3	"0852628"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:15
S22	12	"852628"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 17:15
S23	72	horizontal near6 (flow or reactor) and (sic or silicon near2 carbide) near5 (cvd or chemical near2 vapor near2 deposit\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:01
S24	27	horizontal near6 (flow or reactor) and (sic or silicon near2 carbide) near5 (cvd or chemical near2 vapor near2 deposit\$6) and @py<"2002"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:09
S25	22	horizontal near6 (flow or reactor) and (sic or silicon near2 carbide) near5 (cvd or chemical near2 vapor near2 deposit\$6) and @py<"2002" and (substrate or susceptor) near10 temperature	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:17

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S26	12	horizontal near6 (flow or reactor) and (sic or silicon near2 carbide near4 germanium) near5 (cvd or chemical near2 vapor near2 deposit\$6) and @py<"2002" and (substrate or susceptor) near10 temperature	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:22
S27	0	horizontal near6 (flow or reactor) and (silicon near2 carbide near4 germanium) near5 (cvd or chemical near2 vapor near2 deposit\$6) and @py<"2002" and (substrate or susceptor) near10 temperature	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:18
S28	0	horizontal near6 (flow or reactor) and (silicon near2 carbide near4 germanium) near5 (cvd or chemical near2 vapor near2 deposit\$6) and @py<"2002"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:18
S29	7	(cvd or chemical near2 vapor near2 deposit\$6) near5 (sicge or silicon near2 carbide near2 germanium)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/13 20:23
S30	17	(cvd or chemical near2 vapor near2 deposit\$6) near5 (sicge or silicon near2 carbon near2 germanium)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/19 23:14